

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Safoshi INOUE et al.

Application No.: 10/748,206

Filed: December 31, 2003



Group Art Unit: 2812

Examiner: R. BOOTH

Docket No.: 040852.98

For: MANUFACTURING METHOD OF ACTIVE MATRIX SUBSTRATE , ACTIVE MATRIX  
SUBSTRATE AND LIQUID CRYSTAL DISPLAY DEVICE

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

Pursuant to 37 CFR §1.56, the attention of the Patent and Trademark Office is hereby directed to the references listed on the attached PTO-1449. Unless otherwise indicated herein, one copy of each reference is attached. It is respectfully requested that the information be expressly considered during the prosecution of this application, and that the references be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

- ☒ 1. This Information Disclosure Statement is being filed (a) within three months of the U.S. filing date of this non-CPA application, OR (b) before the mailing date of a first Office Action on the merits in the present application. No certification or fee is required.
- ☒ 2. One or more reference cited herein was cited in a counterpart foreign application. See References 1 and 3.
- ☒ 3. An English language Abstract of one or more non-English language reference is attached hereto. See Reference 3.
- ☒ 4. A computer-generated English language translation of one or more Japanese Patent Publication cited herein has been obtained from the website of the Japanese Patent Office ([<http://www.jpo.go.jp>]), and is attached, but has not been reviewed for accuracy. See Reference 3.
- ☒ 5. Non-English language reference 1 corresponds to English language reference 2.

Respectfully submitted,

James A. Oliff  
Registration No. 27,075

Bogdan A. Zinchenko  
Registration No. 57,473

JAO:BAZ/axl

Date: January 27, 2006

OLIFF & BERRIDGE, PLC  
P.O. Box 19928  
Alexandria, Virginia 22320  
Telephone: (703) 836-6400

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Sheet 1 of 1

Form PTO-1449 (REV. 1/06)		Dept. of Commerce PATENT & TRADEMARK OFFICE		ATTY DOCKET NO. 040852.98		APPLICATION NO. 10/748,206	
INFORMATION DISCLOSURE STATEMENT  (Use several sheets if necessary)				APPLICANTS Satoshi INOUE et al.			
				FILING DATE December 31, 2003		GROUP 2812	
U.S. PATENT DOCUMENTS							
Examiner Initials	Cite No.	Document Number	Date	Name			
FOREIGN PATENT DOCUMENTS							
Examiner Initials	Cite No.	Document Number	Date	Country	With English Abstract	With English Translation	
	1.	JP A 07-504782 (corresponds to reference 2)	05/25/1995	Japan			
	2.	WO 93/16491	08/19/1993	WIPO			
	3.	JP A 07-294961	11/10/1995	Japan	X	X	
OTHER DOCUMENTS							
Examiner Initials	Cite No.	(Including Author, Title, Date, Pertinent Pages, etc.)					
EXAMINER					DATE CONSIDERED		
Examiner: Initial if citation considered, whether or not citation is in conformance with M.P.E.P. 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.							

Date: January 27, 2006